ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

FFS ID:

Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices

Submision Type: Information Disclosure

Statement

Application Number:

09/941827 76168

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First Named Applicant: Ronald Weimer

Attorney Docket Number: MTI-31532

Timestamp: 2005-01-18 10:34:04 EDT

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File Listing:

Doc. Name	File Name	Size (Bytes)	
		1	Produced
			(yyyymmdd)
us-fee-sheet	MTI-31532-usfees.xml		2005-01-18
us-fee-sheet	us-fee-sheet.xsl		2005-01-18
us-fee-sheet	us-fee-sheet.dtd	11968	2005-01-18
us-ids	MTI-31532-usidst.xml		2005-01-18
us-ids	us-ids.dtd		2005-01-18
us-ids	us-ids.xsl		2005-01-18
package-data	MTI-31532-pkda.xml		2005-01-18
package-data	package-data.dtd		2005-01-18
package-data	us-package-data.xsl	19263	2005-01-18
Total files size		109219	

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